

PATENT
Docket No. 150.01180102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Vaartstra)	Group Art Unit:	Unassigned
Serial No.: 10/771,050)	Examiner:	Unassigned
Confirmation No.: Unassigned)		
Filed: February 3, 2004)		
For: METHODS FOR PLANARIZATION OF METAL-CONTAINING SURFACES USING HALOGENS AND HALIDE SALTS)		

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By: Loren D. Albin
Loren D. Albin
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April 26, 2004
Date

Signature: Sara E. Olson
Name: SARA E. OLSON

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For: METHODS FOR PLANARIZATION OF METAL-CONTAINING SURFACES <u>USING HALOGENS AND HALIDE SALTS</u>)			

OFFICIAL

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with C.F.R. §§ 1.97 *et. seq.*, the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Per M.P.E.P. § 609, the information cited in the present Information Disclosure Statement shall not be construed to be an admission that the information is, or is considered to be, material to patentability. Consideration of each of the documents listed on the attached 1449 form(s) is respectfully requested. As this patent application was filed after June 30, 2003, copies of the U.S. patents and U.S. patent application publications listed on the attached 1449 form(s) have not been submitted). Pursuant to the provisions of M.P.E.P. § 609, Applicant further requests that a copy of the 1449 form(s), marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

This application is a continuation of U.S. Patent Application Serial No. 10/771,050, filed February 3, 2004. In accordance with 37 C.F.R. § 1.98(d), copies of documents previously cited by or submitted to the U.S. Patent and Trademark Office in connection with Applicant's prior application(s) listed above, are not included herewith.

Information Disclosure Statement**Page 2 of 2**

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Serial No.: 10/771,050

Filed: February 3, 2004

For: METHODS FOR PLANARIZATION OF METAL-CONTAINING SURFACES USING HALOGENS AND HALIDE SALTS

It is believed that no fee is due, as this Information Disclosure Statement is filed prior to the receipt of any Action on the merits. However, in the event a fee is due, please charge any fee or credit any overpayment to Account No. 13-4895.

The Examiner is invited to contact Applicant's Representatives at the below-listed telephone number, if they can be of any assistance during prosecution of the present application.

CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper is being transmitted by facsimile in accordance with 37 CFR §1.6(d) to the Patent and Trademark Office, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 26th day of April, 2004, at 2:45pm (Central Time).

Sara E. Olson
Name: Sara E. Olson

Apr 26, 2004
Date

Respectfully submitted for
Brian A. Vaartstra

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OMB No. 0651-0011
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	Application Filing Date: February 3, 2004	Group: Unassigned
	Information Disclosure Statement mailed: <u>April 26</u> , 2004	

U.S. PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
		4,035,500	07/12/77	Drafter Jr.			
		4,297,436	10/27/81	Kubortera et al.			
		4,670,306	06/02/87	Salem			
		4,747,907	05/31/88	Acocella et al.			
		4,992,137	02/12/91	Cathey, Jr. et al.			
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		5,711,851	01/27/98	Blalock et al.			
		5,786,259	07/28/98	Kang			

EXAMINER	Date Considered
<small>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>	

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		5,888,906	03/30/99	Sandhu et al.			
		5,916,855	06/29/99	Avanzino et al.			
		5,935,871	08/10/99	Farkas et al.			
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		6,261,157	07/17/01	Bajaj et al.			
		6,278,153	08/21/01	Kikuchi et al.			

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		6,290,736	09/18/01	Evans			
		6,306,012	10/23/01	Sabde			
		6,346,741	02/12/02	Van Buskirk et al.			
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		2002/0050322	05/02/02	Kunisawa et al.			
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		2002/0019088	02/14/02	Basceri et al.			
		2002/0111026	08/15/02	Small et al.			
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		2003/0119316	06/26/03	Klein et al.			
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Examiner Initial	Copy Enclosed	Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
		WO 98/06541	02/19/98	PCT				
		WO 98/36045	08/20/98	PCT				
		WO 99/27581	06/03/99	PCT				
		WO 99/53532	10/21/99	PCT				
		WO 00/31794	06/02/00	PCT				

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	WO 01/44396	06/21/00	PCT				
	WO 00/77107	12/21/01	PCT				
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OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

Examiner Initial	Copy Enclosed	Document Description
		Canterford et al., "Chapter 9: Rhodium and Iridium," <i>Halides of the Transition Elements, Halides of the Second and Third Row Transition Metals</i> , John Wiley & Sons, New York, NY, 1968; pgs. 346-357, publication page, title page (14 pages total).
		DeOrnellas et al., "Challenges for Plasma Etch Integration of Ferroelectric Capacitors in FeRAM's and DRAM's," <i>Integrated Ferroelectrics</i> , 1997;17:395-402.
		DeOrnellas et al., "Plasma Etch of Ferroelectric Capacitors in FeRAMs and DRAMs," <i>Semiconductor International</i> , 1997 Sept.; pgs. 103-104, 106 and 108.
		Ginzburg et al., <i>Analytical Chemistry of Platinum Metals</i> , John Wiley & Sons, New York, cover pg., and 14-15.
		Kim et al., "Chemical Dry Etching of Platinum Using Cl ₂ /CO Gas Mixture," <i>Chem. Mater.</i> , 1998;10:3576-3582.

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		Kwon et al., "Etching properties of Pt thin films by inductively coupled plasma," <i>J. Vac. Sci. Technol.</i> , 1998;A 16(5):2772-6.
		Nakao, "Dissolution of Noble Metals in Halogen-Halide-Polar Organic Solvent Systems," <i>J. Chem. Soc., Chem. Commun.</i> , 1992 March 1; 5:426-7.
		Weast et al., "CRC Handbook of Chemistry and Physics," Chemical Rubber Publishing Company, 1989: D151-154
		Wilberg, <i>Lehrbuch der Anorganischen Chemie</i> , Walter de Gruyter, Berlin, 1985, pg. 1118 (Translation of First Paragraph Only)
		Xu et al., "Chemical Vapor Deposition (CVD) of Iridium and Platinum Films and Gas-Phase Chemical Etching of Iridium Thin Films," <i>Mat. Res. Soc. Symp. Proc.</i> , 1999;541:129-139.
		Webster's II, New Riverside University Dictionary, 1984: pgs. 258,842

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